CLAIMS

What is claimed is:

1. An extreme (EUV) radiation source for generating EUV radiation, said source comprising:

a device for generating at least one stream of a target material, said target material being directed towards a target area;

a first laser source generating a pre-pulse laser beam directed towards the target area; and

a second laser source generating a main pulse laser beam directed towards the target area, said pre-pulse beam having a lower intensity than the main pulse beam, wherein the first laser and the second laser are timed so that the pre-pulse beam arrives at the target area before the main pulse beam, and wherein the main pulse beam interacts with the target material to generate the EUV radiation.

- 2. The source according to claim 1 wherein the main pulse beam and the pre-pulse beam are separated by an angle in the range of 0° 180° at the target area.
 - 3. The source according to claim 2 wherein the angle is about 30°.
 - 4. The source according to claim 2 wherein the angle is about 90°.
- 5. The source according to claim 1 wherein the pre-pulse beam arrives at the target area in the range of 20-200 ns before the main pulse beam.

- 6. The source according to claim 1 further comprising a controller, said controller controlling the timing between the pre-pulse beam and the main pulse beam so as to control the intensity of the EUV radiation generated by the source.
- 7. The source according to claim 6 wherein the controller sets the timing between the pre-pulse beam and the main pulse beam to be less than 160 ns to provide a predetermined percentage of the maximum intensity of the EUV radiation.
- 8. The source according to claim 1 wherein the pre-pulse beam has an energy of about 10-40 mJ and the main pulse beam has an energy of about 0.1 to 1 J.
- 9. The source according to claim 1 wherein the at least one stream of the target material is selected from the group consisting of a frozen stream, a liquid stream, multiple streams and target droplets.
 - 10. The source according to claim 1 wherein the target material is xenon.
- 11. An extreme (EUV) radiation source for generating EUV radiation, said source comprising:

a device for generating at least one stream of a target material, said target material being directed towards a target area;

a laser source generating a laser beam;

a beam splitter responsive to the laser beam and splitting the laser beam into a pre-pulse beam and a main pulse beam, said pre-pulse beam and said main pulse beam being directed towards the target area; and

a delay device for delaying the main pulse beam relative to the pre-pulse beam so that the pre-pulse beam arrives at the target area before the main pulse beam, and wherein the pre-pulse beam generates a weakly ionized plasma at the target area and the main pulse beam generates the EUV radiation.

- 12. The source according to claim 11 wherein the main pulse beam and the pre-pulse beam are separated by an angle in the range of 0° 180° at the target area.
 - 13. The source according to claim 12 wherein the angle is about 30°.
 - 14. The source according to claim 12 wherein the angle is about 90°.
- 15. The source according to claim 11 wherein the pre-pulse beam arrives at a target area in the range of 20-200 ns before the main pulse beam.
- 16. The source according to claim 11 wherein the delay device controls the timing between the pre-pulse beam and the main pulse beam so as to control the intensity of the EUV radiation generated by the source.

- 17. The source according to claim 16 wherein the delay device sets the timing between the pre-pulse beam and the main pulse beam to be less than 160 ns to provide a predetermined percentage of the maximum intensity of the EUV radiation.
- 18. The source according to claim 11 wherein the pre-pulse beam has an energy of about 10-40 mJ and the main pulse beam has an energy of about 0.1 1J.
- 19. The source according to claim 18 wherein the at least one stream of the target material is selected from the group consisting of a frozen stream, a liquid stream, multiple streams and target droplets.
 - 20. The source according to claim 11 wherein the target material is xenon.
- 21. An extreme (EUV) radiation source for generating EUV radiation, said source comprising:

a device for generating at least one stream of a target material, said target material being directed towards a target area; and

a system for generating a main pulse laser beam and a pre-pulse laser beam, wherein the main pulse beam and the pre-pulse beam are timed so that the pre-pulse beam arrives at the target area before the main pulse beam, and wherein the pre-pulse beam generates a weakly ionized plasma at the target area and the main pulse beam generates the EUV radiation.

- 22. The source according to claim 21 wherein the system includes a first laser source for generating the main pulse laser beam and a second laser source for generating the pre-pulse beam.
- 23. The source according to claim 21 wherein the system further includes a controller, said controller providing the timing between the main pulse beam and the pre-pulse beam.
- 24. The source according to claim 23 wherein the controller controls the timing between the pre-pulse beam and the main pulse beam to control the intensity of the EUV radiation generated by the source.
- 25. The source according to claim 24 wherein the controller sets the timing between the pre-pulse beam and the main pulse beam to be less than 160 ns to provide a predetermined percentage of the maximum intensity of the EUV radiation.
- 26. The source according to claim 21 wherein the system includes a single laser source for generating laser pulses and a beam splitter for splitting the laser pulses into the main pulse laser beam and the pre-pulse laser beam, said system further including a delay device for delaying the main pulse laser beam relative to the pre-pulse laser beam.

- 27. The source according to claim 21 wherein the main pulse beam and the pre-pulse beam are separated by an angle in the range of 0° 180° at the target area.
 - 28. The source according to claim 27 wherein the angle is about 30°.
 - 29. The source according to claim 27 wherein the angle is about 90.
- 30. The source according to claim 21 wherein the pre-pulse beam arrives at the target area in the range of 20-200 ns before the main pulse beam.
- 31. The source according to claim 21 wherein the pre-pulse beam has an energy of about 10 40 mJ and the main pulse beam has an energy of about 0.1 to 1 J.
- 32. The source according to claim 21 wherein the at least one stream of the target material is selected from the group consisting of a frozen stream, a liquid stream, multiple streams and target droplets.
- 33. A method for generating EUV radiation, comprising:

 directing a stream or streams of a target material towards a target area;

 directing a pre-pulse laser beam towards the target area; and

 directing a main pulse beam towards the target area, wherein the pre
 pulse beam arrives at the target area before the main pulse beam, and wherein the pre-

pulse beam generates a weak plasma at the target area and the main pulse beam interacts with the plasma to generate the EUV radiation.

- 34. The method according to claim 33 wherein the pre-pulse beam arrives at the target area in the range of 20-200 ns before the main pulse beam.
- 35. The method according to claim 33 further comprising setting the timing between the pre-pulse beam and the main pulse beam to control the intensity of the EUV radiation.
- 36. The method according to claim 35 wherein setting the timing includes reducing the time between the pre-pulse beam and the main pulse beam so that the intensity of the EUV radiation is a predetermined amount less than it's maximum intensity.
- 37. The method according to claim 33 wherein the main pulse beam and the pre-pulse beam arrive at the target area separated by an angle in the range of 0° 180°.
- 38. The method according to claim 33 wherein directing a stream of a target material includes directing a stream of a target material selected from the group consisting of a frozen stream, a liquid stream, multiple streams and target droplets.